IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q84448

Michel PUECH

Appln. No.: 10/516,457 Group Art Unit: 1792

Confirmation No.: 2874 Examiner: Jeffrie Robert LUND

Filed: December 3, 2004

For: HEATER LINER FOR A PLASMA ETCHING REACTOR, AND AN ETCHING

METHOD USING THE LINER

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 20, 2007, please amend the aboveidentified application as follows on the accompanying pages.